

<b>Notice of References Cited</b>	Application/Control No. 10/775,095	Applicant(s)/Patent Under Reexamination IMAI ET AL.	
	Examiner JACKY X. ZHENG	Art Unit 2625	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,550,958 A	08-1996	Hattori, Hiroshi	358/1.16
*	B	US-2002/0044295 A1	04-2002	Tanaka, Chiharu	358/1.13
*	C	US-6,438,638 B1	08-2002	Jones et al.	710/301
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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